

LIST OF PUBLICATIONS
CITED BY APPLICANT

Attorney Docket No.
SEL 170

Serial No.
09/532,915

Applicant
Masahiko HAYAKAWA et al

Filing Date
March 22, 2000

Group
2811

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
A.S.	JP 10-135469	05/22/98	Semiconductor Energy Laboratory Co., Ltd.			10/24/96

OTHER PUBLICATIONS

(Including Author, Title, Date, Pertinent Pages)

A.S.	English abstract re Japanese patent application no. 10-135469, published May 22, 1998.
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EXAMINER:

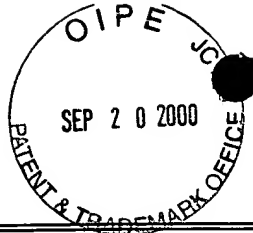
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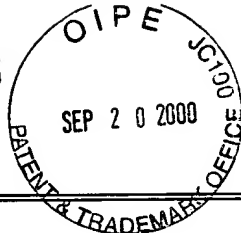
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			<u>Applicant</u> Masahiko HAYAKAWA et al			
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U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
A.S. ↓	5,247,190	09/21/93	Friend et al	257	40	12/28/90
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	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
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	JP 7-130652	05/19/95	Semiconductor Energy Laboratory Co., Ltd.			10/29/93
	JP 7-335900	12/22/95	Semiconductor Energy Laboratory Co., Ltd.			06/09/94
	JP 8-078329	03/22/96	Semiconductor Energy Laboratory Co., Ltd.			09/05/94
	JP 10-092576	04/10/98	Cambridge Display Technology, Ltd.			04/18/97
	JP 10-135468	05/22/98	Semiconductor Energy Laboratory Co., Ltd.			10/24/96
	JP 10-247735	09/14/98	Semiconductor Energy Laboratory Co., Ltd.			03/03/97

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English abstract re Japanese patent application no. 10-135468, published May 22, 1998.
English abstract re Japanese patent application no. 10-247735, published September 14, 1998.

EXAMINER:

Amrith S. Srinivasan

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